

Approved by Examiner 4/5/04 TN

1002270-122004

FIG. 1

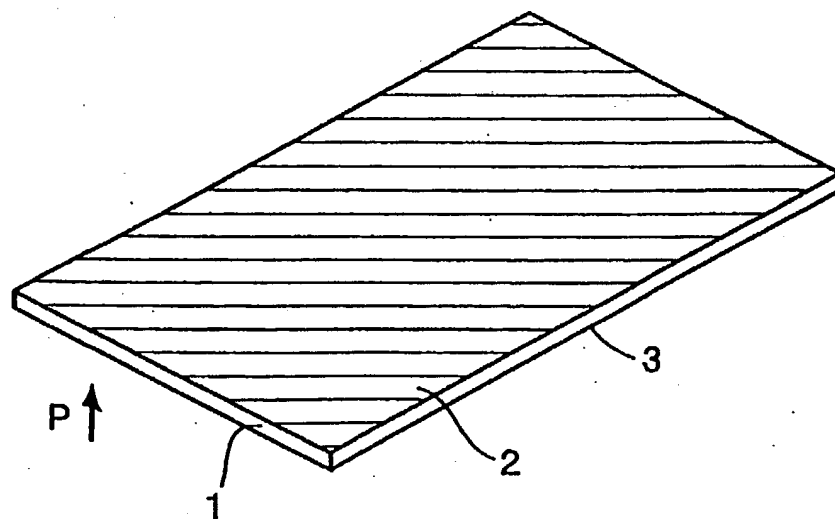
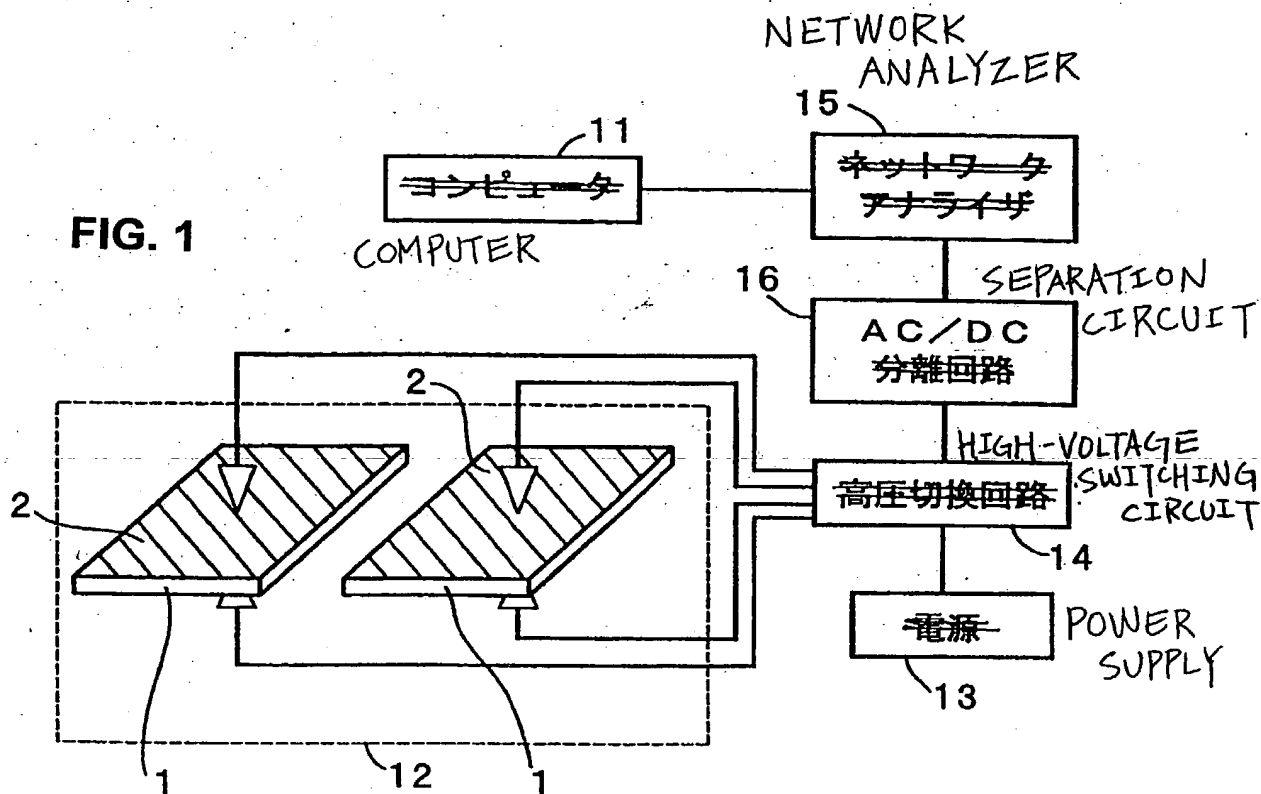


FIG. 2

TOO SET OSCILLATION

RESONANT FREQUENCY OF
FINISHED PRODUCT

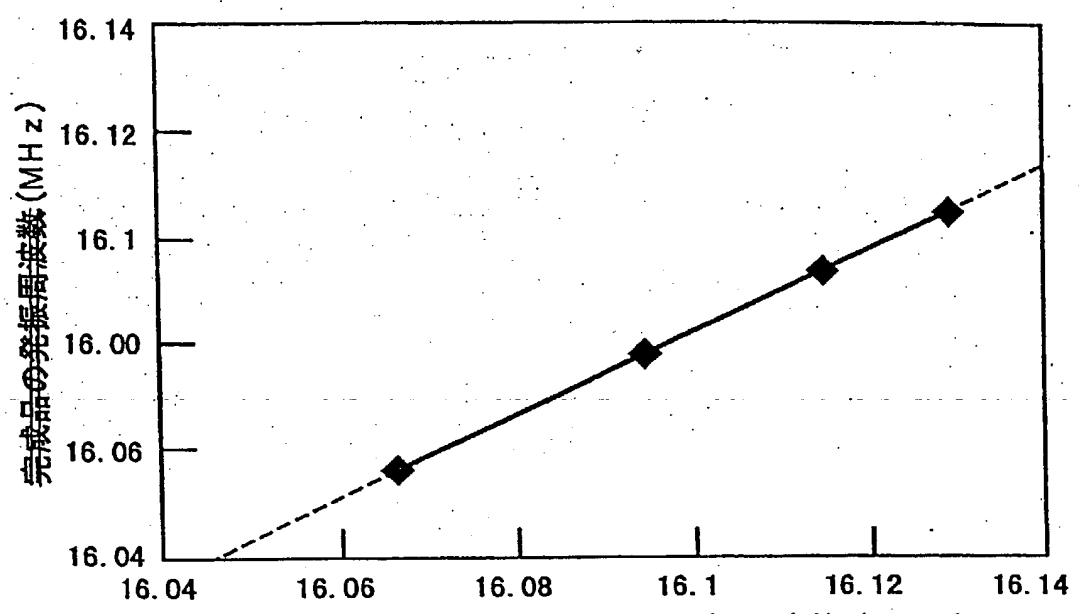


FIG. 5
ANTI-RESONANT FREQUENCY OF MOTHER SUBSTRATE AT ROOM TEMPERATURE

ANTI-RESONANT FREQUENCY OF
MOTHER SUBSTRATE AT ROOM
TEMPERATURE

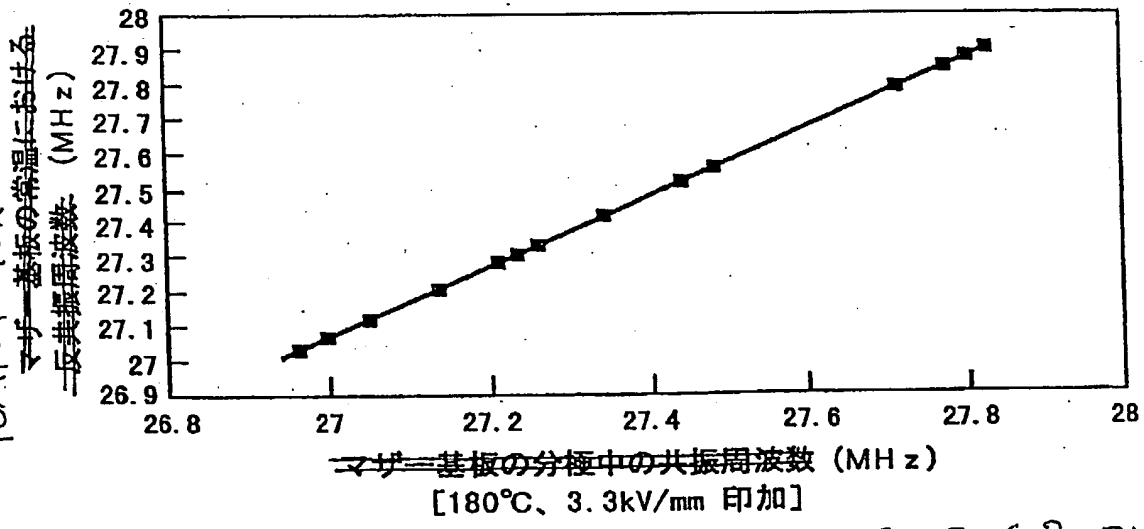


FIG. 6
RESONANT FREQUENCY OF MOTHER SUBSTRATE DURING POLARIZATION

FIG. 6

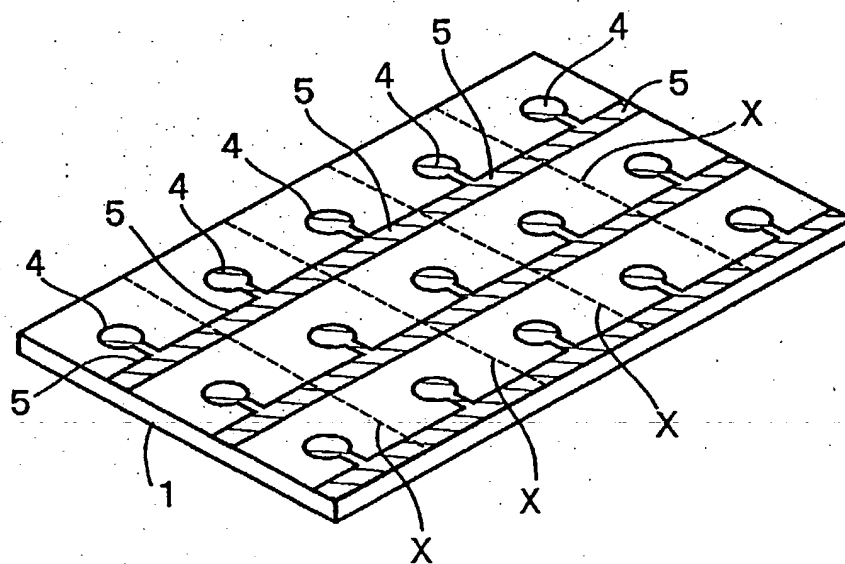
[illegible]

FIG. 3

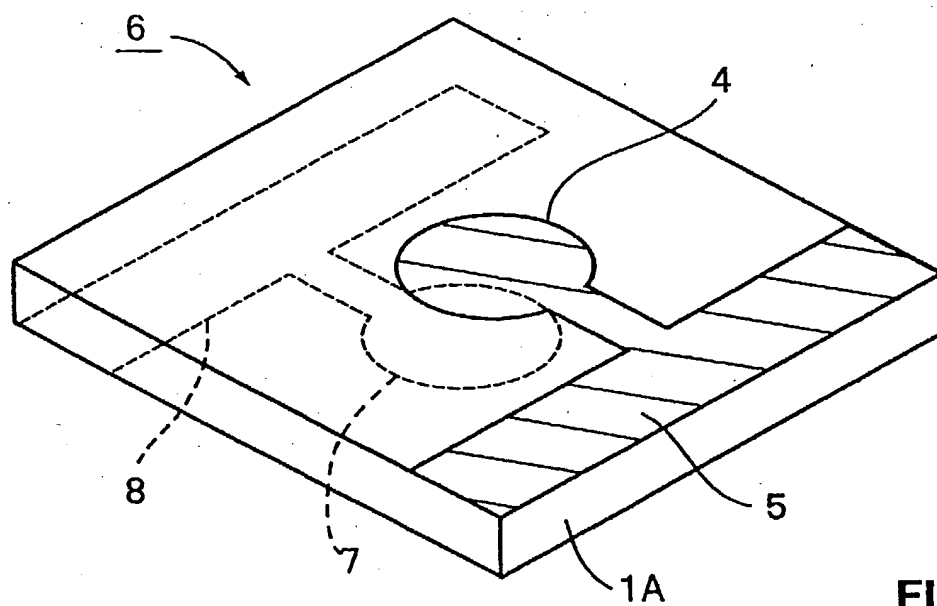


FIG. 4

FIG. 7

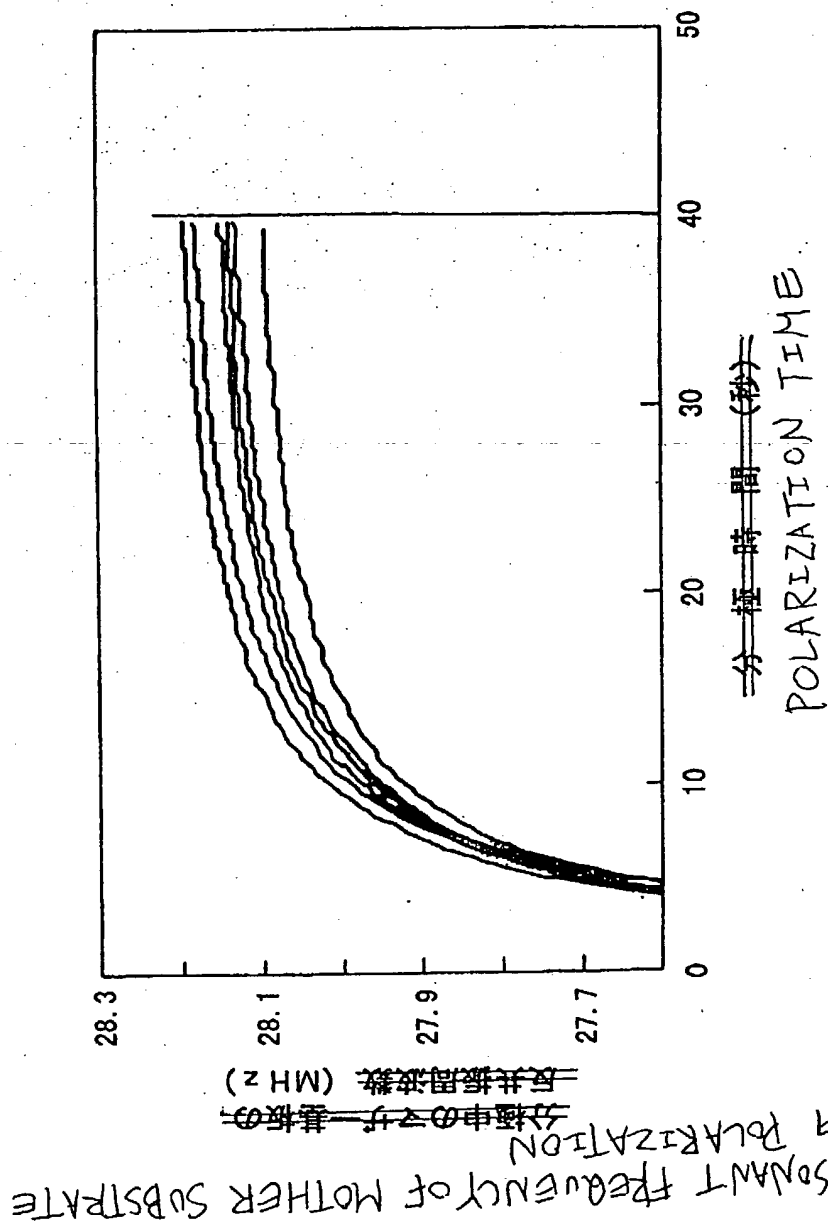


FIG. 7

100221-6222001

ANTIRESONANT FREQUENCY OF MOTHER
SUBSTRATE DURING POLARIZATION

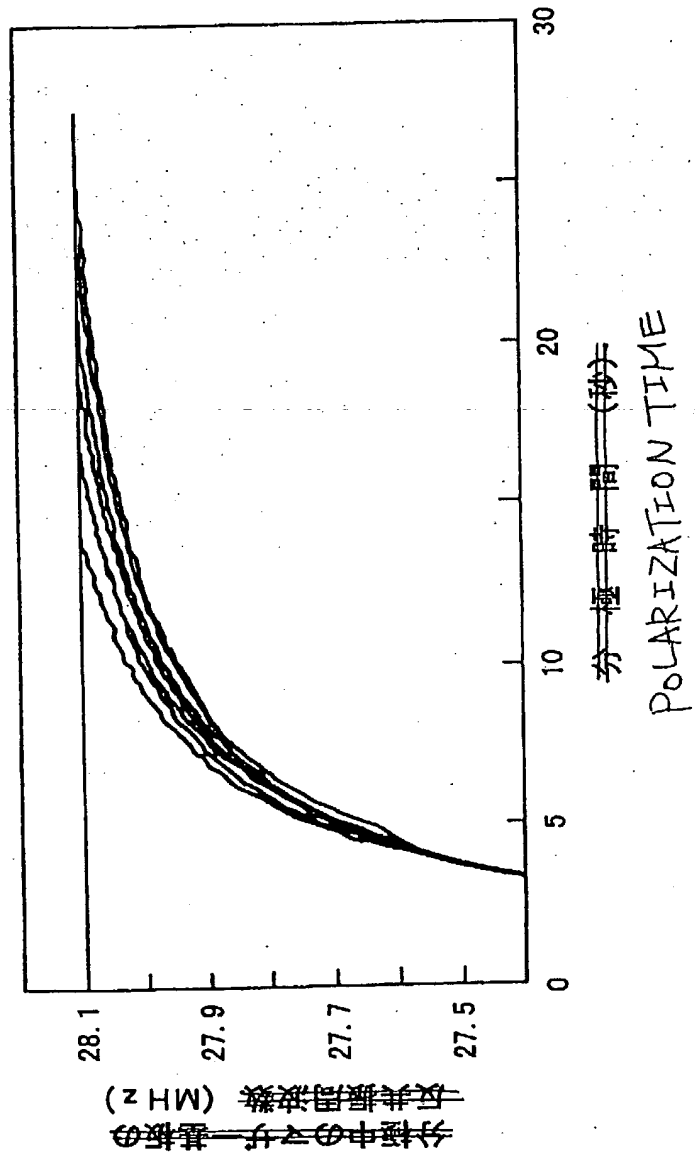


FIG. 8

APPROVED	O.G. FIG. 14	
BY	CLASS	SUBCLASS
DRAFTSMAN	29	25.35

APPLN. FILING DATE: DECEMBER 20, 2001
 TITLE: MANUFACTURING METHOD FOR CERAMIC
 OSCILLATOR
 INVENTOR: NAOKI FUJII ET AL.
 APPLICATION SERIAL NO: 10/022,278

SHEET 1 of 5

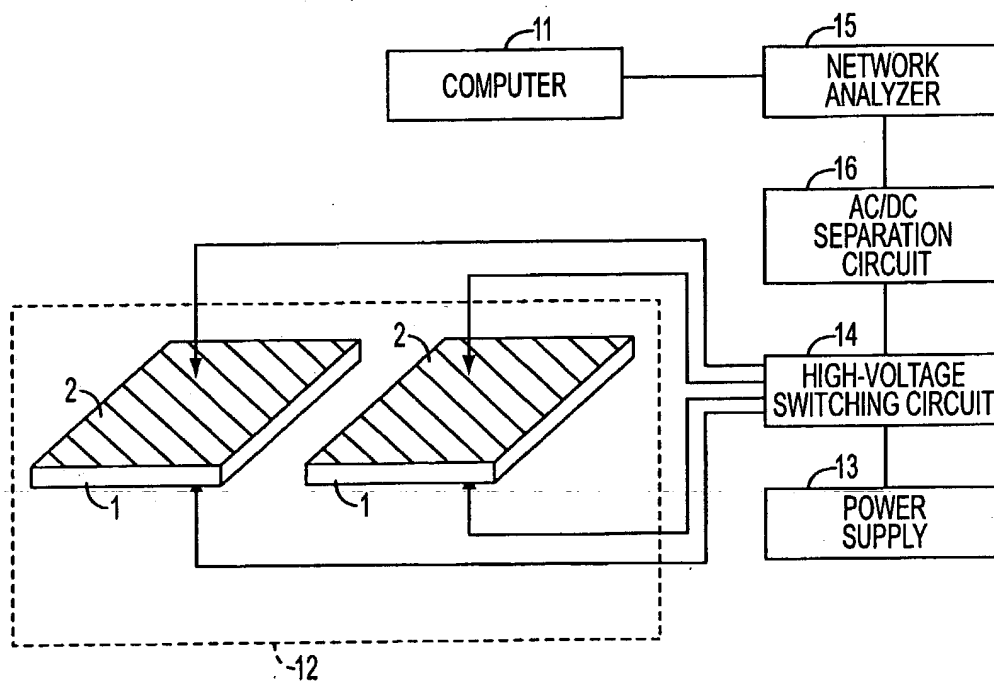


FIG. 1

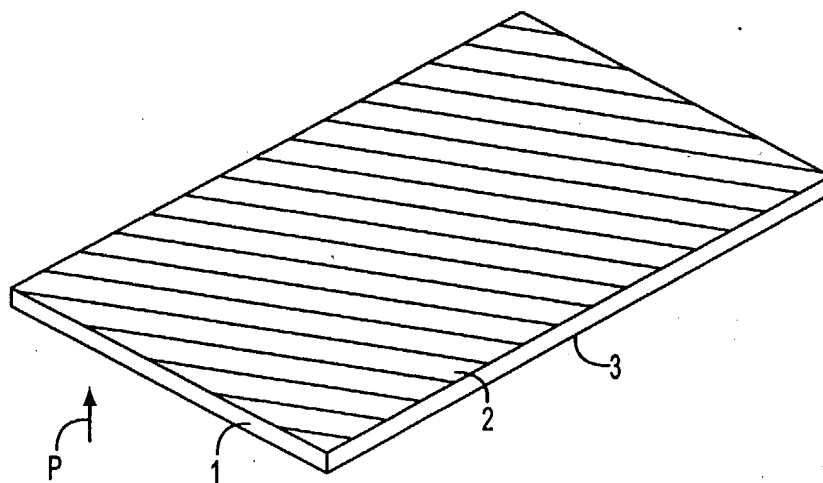


FIG. 2

APPROVED	O.G. FIG. 1+4	
BY	CLASS	SUBCLASS
DRAFTSMAN	29	25.35

APPLN. FILING DATE: DECEMBER 20, 2001
 TITLE: MANUFACTURING METHOD FOR CERAMIC
 OSCILLATOR
 INVENTOR: NAOKI FUJII ET AL.
 APPLICATION SERIAL NO: 10/022,278

SHEET 2 of 5

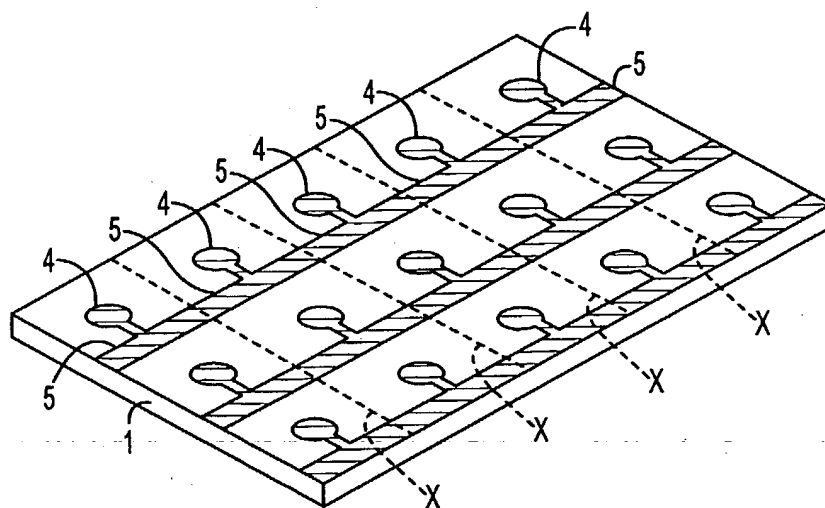


FIG. 3

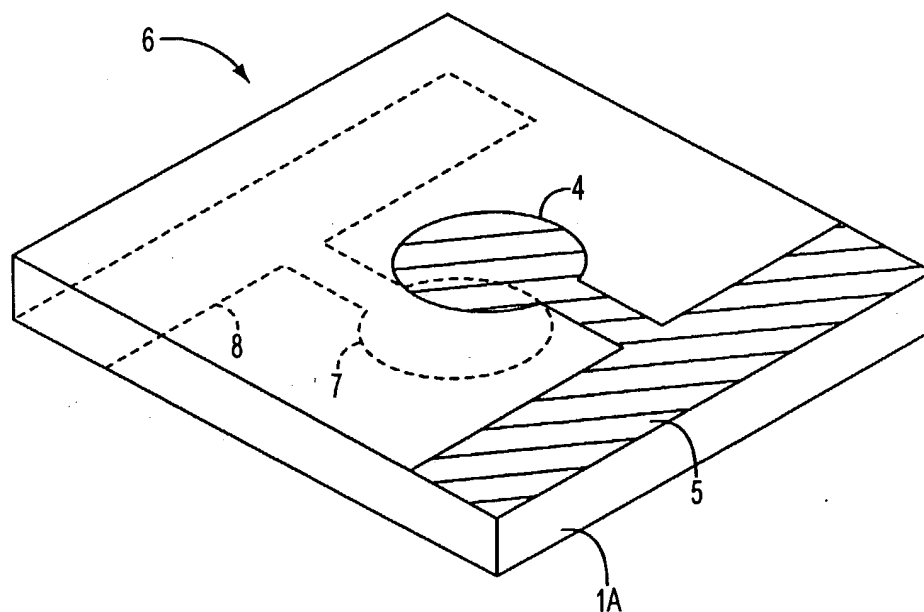


FIG. 4

APPROVED	O.G. FIG.	
BY	CLASS	SUBCLASS
DRAFTSMAN		

APPLN. FILING DATE: DECEMBER 20, 2001
 TITLE: MANUFACTURING METHOD FOR CERAMIC
 OSCILLATOR
 INVENTOR(S): NAOKI FUJII ET AL.
 APPLICATION SERIAL NO: 10/022,278

SHEET 3 of 5

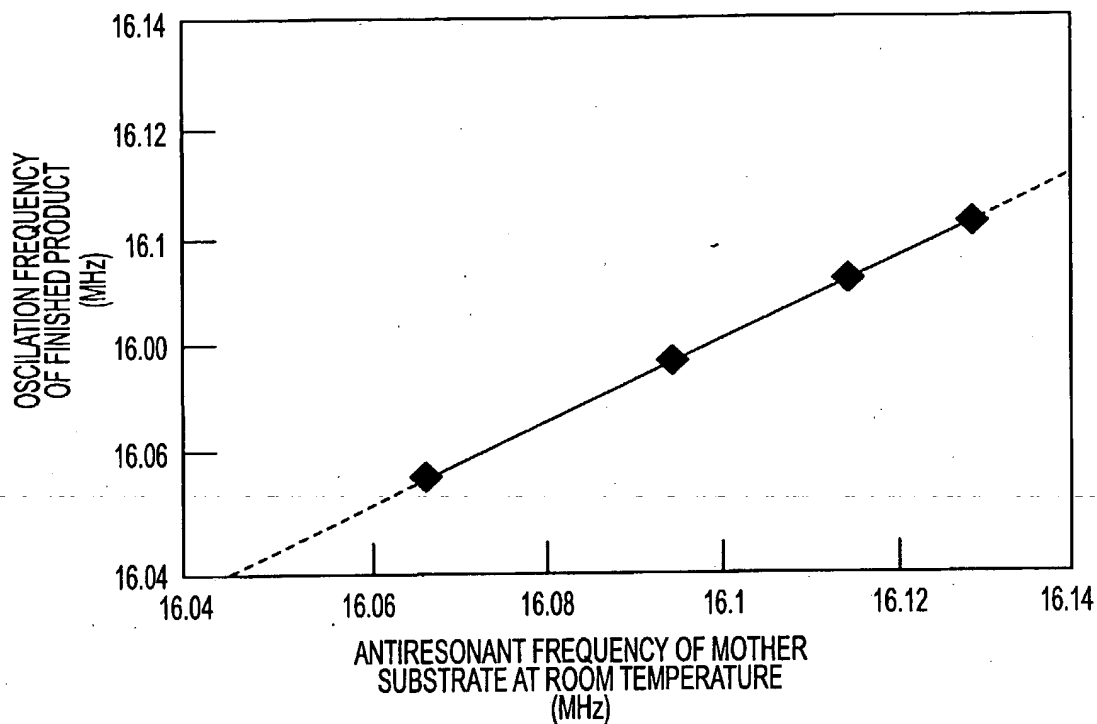


FIG. 5

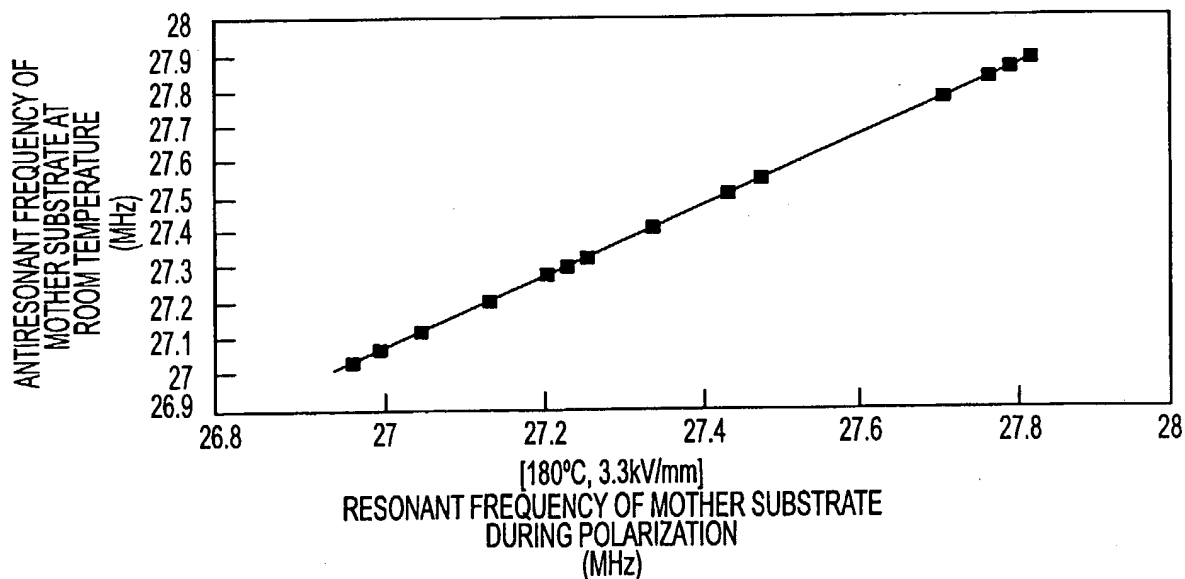


FIG. 6

APPROVED	O.G. FIG.	
BY	CLASS	SUBCLASS
DRAFTSMAN		

2001-12-20 10:22:00

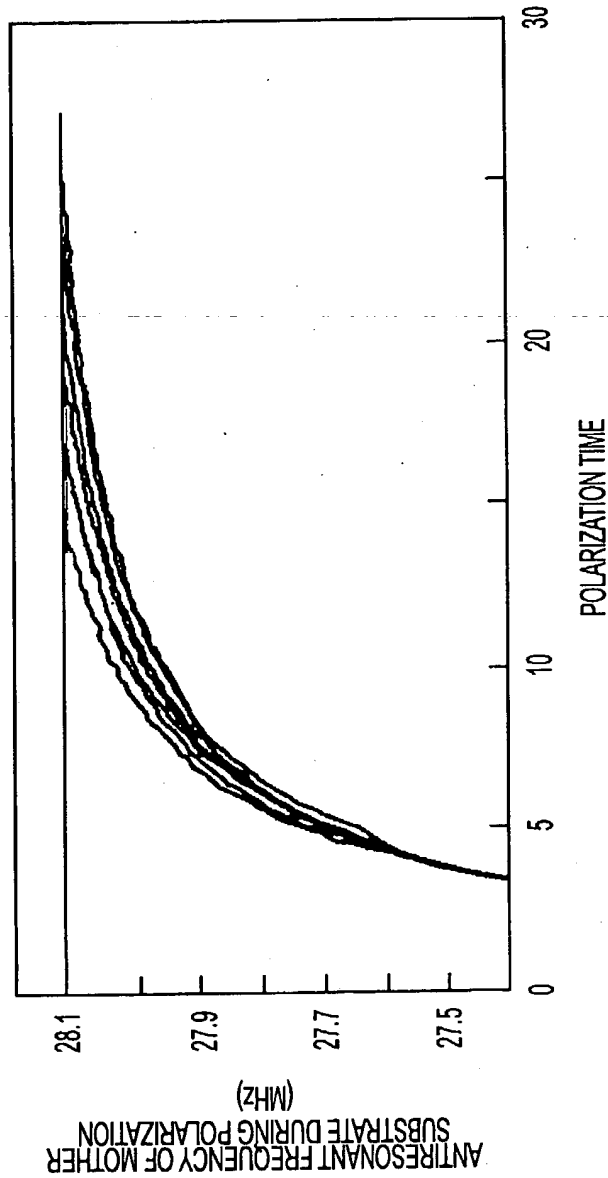


FIG. 8